

U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/1931.P1/CPI/ COPPER/PJS	Serial No. 10/052,681
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant Xi, et al.	Confirmation No. 4083
(Use several sheets if necessary)		Filing Date January 17, 2002	Group 2814
Examiner Ginette Peralta			

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
GP	A1	6,607,977	08/19/2003	Rozbicki, et al.	438	627	09/26/2001
GP	A2	6,498,091	12/24/2002	Chen, et al.	438	627	11/01/2000
GP	A3	2003/0087520	05/08/2003	Chen, et al.	438	643	11/07/2002
GP	A4	2002/0185370	12/12/2002	Gopalraja, et al.	204	192.17	07/16/2002
GP	A5	2002/0029958	03/14/2002	Chiang, et al.	204	192.1	06/20/2001
	A6						
	A7						
	A8						
	A9						
	A10						
	A11						
	A12						
	A13						

Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
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	B2						<input type="checkbox"/>	<input type="checkbox"/>
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	B5						<input type="checkbox"/>	<input type="checkbox"/>

OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
	C1	
	C2	

Examiner <i>Ginette Peralta</i>	Date Considered 12/10/03
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

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GP	A1	6,297,114	10/02/2001	Iwata, et al.	438	305	12/04/1998
GP	A2	5,792,272	08/11/1998	Van Os, et al.	118	723 IR	08/12/1997
GP	A3	5,759,635	06/02/1998	Logan	427	490	07/03/1996
GP	A4	5,565,074	10/15/1996	Qian, et al.	204	298.08	07/27/1995
GP	A5	5,397,962	03/14/1995	Moslehi	315	111.51	06/29/1992
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	A7						
	A8						
	A9						
	A10						
	A11						
	A12						
	A13						

F reign Patent Documents

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OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
GP	C1	Ghandhi, Sorab K., "VLSI Fabrication Principles, Silicon and Gallium Arsenide" Second Edition, Wiley-Interscience Publication (1994), Pages 617-620 and Page 652.
	C2	

Examiner *Ginette Peralta* Date Considered *12/10/03*

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